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ABSTRACT OF THE DISCLOSURE

2 A gate structure in a transistor and method for fabricating the structure. A gate structure is formed on 3 a substrate. The gate structure includes three layers: an 4 oxide layer, a nitride layer and a polysilicon layer. oxide layer is located on the substrate, the nitride layer 6 is located on the oxide layer, and the polysilicon layer is 7 located on the nitride layer. The gate structure is 8 reoxidized to form a layer of oxide over the gate 9 10 structure.

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